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PATENT Attorney Docket No. 401479

IN THE UNITED-STATES PATENT AND TRADEMARK OFFICE

In re Application of:

IZUO et al.

Application No. 10/009,521

Art Unit: 1742

Examiner: D. Valentine

Filed: December 11, 2001

For: ELECTROCHEMICAL ETCHING

METHOD AND APPARATUS AND PRODUCT MANUFACTURED

THEREBY

RESPONSE TO OFFICE ACTION

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 4, 2003, please enter the following amendments and consider the following remarks.

11/12/2003 MLAWRENC 00000001 121216 10009521

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86.00 DA